



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Nunan et al.

Atty. Docket: 2550/193

Serial No.: 10/791,638

Art Unit: 2891

Filing Date: March 2, 2004

Date: December 23, 2005

Invention: SINGLE CRYSTAL SILICON SENSOR WITH ADDITIONAL LAYER AND METHOD OF PRODUCING THE SAME

Examiner: Bradley Smith

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, PO Box 1450 Alexandria, VA 22313-1450 on December 23, 2005.

Steven G. Saunders

SECOND PRELIMINARY AMENDMENT

Sir:

In response to the office action dated November 23, 2005, please amend the above-identified patent application as follows:

Amendments to the Drawings are listed beginning on page 2 of this paper and include both an attached replacement sheet and an annotated sheet showing changes.

Remarks begin on page 3 of this paper.